

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Prior Application: S. NUMAZAWA et al
Serial No. 10/325,915
Filed: December 23, 2002

Group Art Unit 2825
Examiner: B. Keshavan
For: METHOD OF FABRICATING SEMICONDUCTOR
DEVICE

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

February 25, 2004

Sir:

Prior to examination, please amend the above application
as follows.